

Notice of Revision of EMC Testing Service Use Charges

Thank you for your continued support.

In conjunction with the addition of new test items, we are setting new service use charges. Details are provided below.

We will continue our efforts to enhance quality and service even further so that customers can use our products with satisfaction, and we request your understanding regarding the revised service use charges.

Details of revisions

1. Charges for use of the 10 m method anechoic chamber in building E3
The charge for IEC61000-4-4/-5 has been changed to 350,000 yen.
A new charge for CISPR25 has been set at 300,000 yen.
A new charge for IEC61000-3-2/-3 has been set at 350,000 yen.
A new charge for IEC61000-3-11/-12 has been set at 400,000 yen.
A new charge for EN62311 has been set at 300,000 yen.
2. Charges for use of the 3 m method anechoic chamber in building E3
The charge for IEC61000-4-4/-5 has been changed to 200,000 yen.
A new charge for IEC61000-3-2/-3 has been set at 200,000 yen.
A new charge for IEC61000-3-11/-12 has been set at 250,000 yen.
A new charge for EN62311 has been set at 200,000 yen.
3. Charges for use of the shielded room in building E3
The charge for IEC61000-4-4/-5 has been changed to 150,000 yen.
A new charge for CISPR25 has been set at 120,000 yen.
A new charge for ISO11452-4 (SLD_S) has been set at 120,000 yen.
A new charge for IEC61000-3-2/-3 has been set at 150,000 yen.
A new charge for IEC61000-3-11/-12 has been set at 200,000 yen.
A new charge for EN62311 has been set at 150,000 yen.
4. Overtime charges for use after business hours for all facilities
There are no changes to the overtime charges.
5. Effective date of revised charges
The revised charges shall take effect for use starting on July 1, 2021.
6. Contact
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